

Electronic Acknowledgement Receipt

EFS ID:	4745837
Application Number:	10544783
International Application Number:	
Confirmation Number:	5339
Title of Invention:	Method for forming nickel silicide film, method for manufacturing semiconductor device, and method for etching nickel silicide
First Named Inventor/Applicant Name:	Koichi Terashima
Customer Number:	23373
Filer:	Howard Leonard Bernstein/Michael Abrams
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Attorney Docket Number:	Q89627
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Application Type:	U.S. National Stage under 35 USC 371

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement Letter	IDS.pdf	60858 888ad815d4e8507dded6f71d2cc52a81b3d92 4895b	no	2

Warnings:

Information:

2	NPL Documents	Japanese_OA_with_translation.pdf	227030 3071a88cd8dc18198f848a7b156ceca2892f95e78a	no	5
Warnings:					
Information:					
Total Files Size (in bytes):			287888		
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